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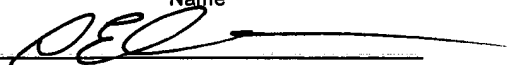
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Our File No. CYP01-042-CON-US

Paul E. Rauch, Ph.D.

Name



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Benjamin Schwarz, et al

Serial No. 10/791,657

Filing Date: March 2, 2004

For GATE ETCH PROCESS

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) Examiner To Be Assigned
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) Group Art Unit No. 2655
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INFORMATION DISCLOSURE STATEMENT

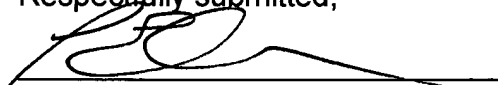
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Dear Sir:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, be made during the course of examination of the above-referenced application for United States Letters Patent.

This application is a continuation application of Serial No. 10/099,841. Accordingly, all information previously submitted to and/or cited by the Examiner is not provided, according to 37 C.F.R. § 1.98(d).

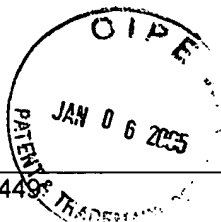
Respectfully submitted,



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Form PTO-1449 (Rev. 8-88)	Attorney Docket No. CYP01-042-CON-US	Serial No. 10/791,657
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Applicant: Benjamin Schwarz, et al	
	Filing Date: March 2, 2004	Group: 2655

U.S. PATENT DOCUMENTS

Examiner Initials*		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	A1	4,174,251	11/1979	Paschke			
	A2	4,568,410	2/1986	Thornquist			
	A3	4,654,114	3/1987	Kadomura			
	A4	4,808,259	2/1989	Jillie, et al.			
	A5	5,279,705	1/1994	Tanaka			
	A6	5,928,967	7/1999	Radens, et al.			
	A7	5,989,979	11/1999	Liu, et al.			
	A8	6,235,644	5/2001	Chou			
	A9	6,296,780	10/2001	Yan, et al.			
	A10	6,307,174	10/2001	Yang, et al.			
	A11	6,379,872	4/2002	Hineman, et al.			
	A12	6,399,514	6/2002	Marks, et al.			
	A13	6,428,716	8/2002	Demmin, et al.			
	A14	6,451,703	9/2002	Liu, et al.			
	A15	6,461,969	10/2002	Lee, et al.			

Examiner Initials*	OTHER ITEMS - NON PATENT LITERATURE DOCUMENTS	
	Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages	
	A16	Wolf, "Silicon Processing for the VLSI Era", vol. 1-Process Technology, pp. 550-556, November, 1999.

Examiner	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.